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PATENT NUMBER and
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U.S. UTILITY Patent Application

APPL NUM 10049170	FILING DATE 05/22/2002	CLASS 156	SUBCLASS 89.12	GAU 1734	EXAMINER MAYES
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****APPLICANTS:** Hashimoto Akira;

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****CONTINUING DATA VERIFIED:**
THIS APPLICATION IS A 371 OF PCT/JP01/04818 06/07/2001

**** FOREIGN APPLICATIONS VERIFIED:**
JAPAN 2000-170117 06/07/2000

PG-PUB	DO NOT PUBLISH <input type="checkbox"/>	RESCIND <input type="checkbox"/>
Foreign priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no Verified and Acknowledged Examiners's initials <i>MM</i>		ATTORNEY DOCKET NO MAT-8211US
TITLE : Method for producing ceramic substrate		

U.S. DEPT. OF COMM./PAT. & TM.-PTO-436L (Rev. 12-94)

NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
ISSUE FEE Amount Due: _____ Date Paid: _____		Total Claims: _____ First Claim for O.G. _____	
<input type="checkbox"/> TERMINAL DISCLAIMER		DRAWING Sheets Drawn: _____ Printed: _____	
PREPARED FOR ISSUE		Application Examiner	
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